

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet

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of

<b>Complete if Known</b>	
<i>Application Number</i>	10/581,497
<i>Filing Date</i>	June 2, 2006
<i>First Named Inventor</i>	Babak HEIDARI
<i>Art Unit</i>	1791
<i>Examiner Name</i>	Stephen J. SÖLLENBERGER
<i>Attorney Docket Number</i>	02386.0105

**U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS**

Examiner Initials	Cite No. <sup>1</sup>	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
		US 4,844,947	07/04/1989	Kasner et al.	
		US 6,027,630	02/22/2000	Cohen	
		US 6,284,345	09/04/2001	Ruoff	
		US 7,374,864	05/20/2008	Guo et al.	
		US 2004/0079730	04/29/2004	Ahrens et al.	

Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

**FOREIGN PATENT DOCUMENTS**

Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation <sup>6</sup>
		Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)				
		JP 2000-194142	07-14-2000	Fujitsu Ltd		Abstract

**NONPATENT LITERATURE DOCUMENTS**

Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation <sup>6</sup>
		WISSEN et al., "UV CURING OF RESISTS FOR WARM EMBOSsing", Elsevier B.V., Microelectronic Engineering, Vol. 73-74, pp. 184-187, (2004).	
		REANO et al., "STABILITY OF FUNCTIONAL POLYMERS AFTER PLASTICIZER-ASSISTED IMPRINT LITHOGRAPHY", Journal of Vacuum Science & Technology, American Vacuum Society, Vol. 22, No. 6, pp. 3294-3299, (2004).	
		BENDER et al., "FABRICATION OF NANOSTRUCTURES USING A UV-BASED IMPRINT TECHNIQUE", Elsevier B.V., Microelectronic Engineering, Vol. 53, pp. 233-236, (2000).	
Examiner Signature		Date Considered	

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